

In re Application of:

TOSHIKAZU ONISHI ET AL.

Application No.: 10/014,131

Filed: December 13, 2001

For: METHOD FOR MANUFACTURING  
ELECTRON EMISSION ELEMENT  
ELECTRON SOURCE, AND IMAGE  
FORMING APPARATUS



Docket No. 03500.013314.2

Examiner: K. Ramsey

Group Art Unit: 2879

April 30, 2003

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COMMISSIONER FOR PATENTS  
Washington, D.C. 20231

Sir:

Transmitted herewith is an amendment in the above-identified application.

☒ No additional fee is required.

The fee has been calculated as shown below

CLAIMS AS AMENDED						
	(2) CLAIMS REMAINING AFTER AMENDMENT		(4) HIGHEST NO. PREVIOUSLY PAID FOR	(5) PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	* 10	MINUS	** 20	= 0	x \$9 \$18	\$ 0.00
INDEP. CLAIMS	* 6	MINUS	*** 3	= 0	x \$42 \$84	\$ 252.00
Fee for Multiple Dependent claims \$140°/\$280						\$ 0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT---						\$ 252.00

- \* If the entry in Column 2 is less than the entry in Column 4, write "0" in Column 5.  
\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 20, write "20" in this space.  
\*\*\* If the "Highest Number Previously Paid For" IN THIS SPACE is less than 3, write "3" in this space.

☐ Verified Statement claiming small entity status is enclosed, if not filed previously.

☒ A check in the amount of \$ 252.00 is enclosed.

☐ Charge \$ \_\_\_\_\_ to Deposit Account No. 06-1205. A duplicate copy of this sheet is enclosed.

☒ Any prior general authorization to charge an issue fee under 37 C.F.R. 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Commissioner is hereby authorized to charge any additional fees under 37 C.F.R. 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate copy of this paper is enclosed.

☐ A check in the amount of \$ \_\_\_\_\_ to cover the fee for a \_\_\_\_\_ month extension is enclosed.

☐ A check in the amount of \$ \_\_\_\_\_ to cover the Information Disclosure Statement fee is enclosed.

☒ Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Peter G. Thulow  
Attorney for Applicants

Registration No. 47,138

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03500.013314.2

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )

TOSHIKAZU ONISHI ET AL. )

Application No.: 10/014,131 )

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For: METHOD FOR MANUFACTURING )  
ELECTRON EMISSION ELEMENT, :  
ELECTRON SOURCE, AND IMAGE )  
FORMING APPARATUS :

Examiner: K. Ramsey

Group Art Unit: 2879

April 30, 2003

# 68 Amet  
M. Brauns  
5/18/02

Commissioner of Patents  
Washington, D.C. 20231

AMENDMENT

Sir:

In response to the Office Action of January 30, 2003, please amend the  
above-identified application as follows.

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope addressed  
to: Commissioner for Patents, Washington, D.C. 20231 on

April 30, 2003

(Date of Deposit)

PETER G. THURLOW (Reg No. 47,138)

(Name of Attorney for Applicants)

*Peter G. Thurlow*  
Signature

April 30, 2003  
Date of Signature

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The present Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice entitled "Amendments in a Revised Format Now Permitted," a copy of which is attached. The Revised Format was authorized by the U.S. Patent and Trademark Office as of December 2002, and will be mandatory as of July 2003.

The amendments to the claims are reflected in the claim listing beginning at page 3; the remarks begin at page 7.